## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:

: Mami MIYASAKA

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: ELECTRON BEAM EXPOSURE MASK,...

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## PRIORITY CLAIM AND

## **SUBMISSION OF PRIORITY DOCUMENT**

SIR:

Applicant hereby claims priority under 35 USC 119 from **Japanese** patent application number 11-232358 filed **August 19, 1999**, a copy of which was made of record in parent application number 09/641,125.

Respectfully submitted,

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